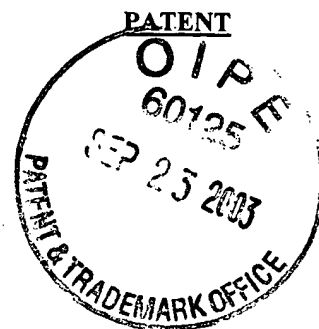


Docket No.: 67161-106

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Yasuhiro SATO : Confirmation Number:
Serial No.: : Group Art Unit:
Filed: September 23, 2003 : Examiner:



For: REGISTRATION CORRECTION AMOUNT CALCULATING APPARATUS FOR CALCULATING
AMOUNT OF CORRECTION FOR REGISTRATION INSPECTION APPARATUS FROM
REGISTRATION INSPECTION DATA OF PATTERN FORMED ON WAFER

**CLAIM OF PRIORITY AND
TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT**

Mail Stop CPD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicant hereby claim the priority of:

Japanese Patent Application No. 2003-100606(P), filed on April 3, 2003.

cited in the Declaration of the present application. A certified copy is submitted herewith.

Respectfully submitted,

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Date: September 23, 2003

Yasuhiro SATO

September 23, 2003

日 本 国 特 許 庁

JAPAN PATENT OFFICE

McDermott, Will & Emery

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出 願 年 月 日

Date of Application:

2003年 4月 3日

出 願 番 号

Application Number:

特願2003-100606

[ST.10/C]:

[JP2003-100606]

出 願 人

Applicant(s):

株式会社ルネサステクノロジ

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2003年 6月10日

特 許 庁 長 官
Commissioner,
Japan Patent Office

太田信一郎

出証番号 出証特2003-3045241